

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/550,459 Confirmation No. : 4620
First Named Inventor : Decams, Jean-Manuel
Filed : December 12, 2006
TC/A.U. : 1792
Examiner : Michael G. Miller

Docket No. : 104003.B130130
Customer No. : 23911

Title : Method for CVD Deposition of a Silver Film on a Substrate

AMENDMENT AND RESPONSE UNDER 37 C.F.R. § 1.116

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In complete response to the final Office Action dated January 13, 2009, Applicants submit herewith a Petition for a one month extension of time, extending the period of response from April 13, 2009 to May 13, 2009, and the following Response.

Listing of Claims begins on page 2 of this Response.

Remarks begin on page 4 of this Response.